

<b>Notice of References Cited</b>	Application/Control No. 10/720,579		Applicant(s)/Patent Under Reexamination KIM ET AL.	
	Examiner EDNA WONG		Art Unit 1795	Page 1 of 1

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*	B	US-5,863,410	01-1999	Yates et al.	205/585
*	C	US-5,863,666	01-1999	Merchant et al.	428/544
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
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